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Docket No.: SUG-192-PCT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Serial No.: **TO BE ASSIGNED**

Confirmation No.: **TO BE ASSIGNED**

Applicant: **Toru YAMADA, et al.**

Art Unit: **TO BE ASSIGNED**

Filed: **June 14, 2006**

Examiner: **TO BE ASSIGNED**

Docket No: **SUG-192-PCT**

Customer No: **28892**

For: **Vapor Phase Growth Apparatus and Method of Fabricating Epitaxial Wafer**

**PRELIMINARY AMENDMENT**

US Patent & Trademark Office

Customer Service Window, Mail Stop: **PATENT APPLICATIONS**

Randolph Building

401 Dulany Street

Alexandria, VA 22314

Sir:

After assigning a serial number to the above-captioned application and before calculating the fee, please undertake the following changes:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins

on page 3 of this paper.

**Remarks** begin on page 11 of this paper.

**An Appendix** including an Abstract is attached following page 11 of this paper.